

FORM PTO-1449		Docket N. : 008 D-6836		Appl. No.: 09/170,625		
<b>INFORMATION DISCLOSURE CITATION IN AN APPLICATION</b>		Applicant Duck-Kyun Choi				
(Use several sheets if necessary)		Filing Date: 10/13/98		Gr up Art Unit: 2813		
<b>U.S. PATENT DOCUMENTS</b>						
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	5426064	6/20/1995	Zhang et al.			
	5488000	1/30/1996	Zhang et al.			
	5481121	1/2/1996	Zhang et al.			
	5569610	10/29/1996	Zhang et al.			
	5501989	3/26/1996	Takayama et al.			
	5550070	8/27/1996	Funai et al.			
	5508533	4/16/1996	Takemura			
	5275851	1/4/1994	Fonash et al.			
	5147826	9/15/1992	Liu et al.			
	5543352	8/6/1996	Ohtani et al.			
	5529937	6/25/1996	Zhang et al.			
	5534716	7/9/1996	Takemura			
	5403763	4/4/1995	Yamazaki			
	5403772	4/4/1995	Zhang et al.			
	<b>OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)</b>					
	K.S. Song, S.H. Park, S.I. Jun and D.K. Choi, "A Crystallization of the Amorphous Silicon Using Field Aided Lateral Crystallization" Department of Inorganic Materials Engineering, Hanyang University, 1997, pp.144 - 150. (Abstract only)					
	Materials Research Society, Abstracts, April 13 - 17, 1998, p. 55.					
9	Kyung-Sub Song and Duck-Kyun Choi, "Electric Field Effect on the Metal Induced Crystallization of Amorphous Silicon," Proceedings of the Eighth International Symposium on Silicon-on Insulator Technology and Devices, Volume 97-23, pp. 75 - 80, 8/31/1997.					
Pg. 243	Seung-Ik Jun, Kyung-Sub Song, Sang-Hyun Park and Duck-Kyun Choi, "Fabrication of Low Temperature Poly-Silicon Thin Film Transistor Using Field Aided Lateral Crystallization (FALC)," The First Asian-European International Conference on Plasma Surface Engineering, October 5-9, 1997.					
Pg. 243 only	Kyung-Sub Song, Seung-Ik Jun, Sang-Hyun Park and Duck-Kyun Choi, "Enhanced Crystallization of Amorphous Silicon Using Electric Field," Proc. the 12th KACG Tech. Meeting and the 4th Korea-Japan EMGS, 6/12/1997. (pp. 243 only)					
	Y. Masaki, P. G. LeComber, and A. G. Fitzgerald, "Solid Phase Crystallization of Thin Films of Si Prepared by Plasma-Enhanced Chemical Vapor Deposition," J. Appl. Phys. 74 (1), July 1, 1993, pp. 129-134.					
	Dong Kyun Sohn, Jeong No Lee, Sang Won Kang and Byung Tae Ahn, "Low-Temperature Crystallization of Amorphous Si Films By Metal Adsorption and Diffusion," Jpn. J. Appl. Phys., Vol. 35 (1996) Pt. 1, No. 2B, pp. 1005-1009.					
EXAMINER		DATE CONSIDERED				
		5/25/00				
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.						